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Attorney Docket: 025403-0305451

Client Reference: A2003-S0213US/SPO200512-0081US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
SHIM et al.

Confirmation Number: 6221

Application No.: 10/747,946

Group Art Unit: 2813

Filed: December 31, 2003

Examiner: Nguyen, Thanh T.

Title: A SUBMICRON SEMICONDUCTOR DEVICE AND A FABRICATING METHOD
THEREOF

AMENDMENT UNDER 37 C.F.R. §1.312

Mail Stop Issue Fee
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following amendment and remarks regarding the above-identified allowed application. It is respectfully submitted that the following amendment does not present any new issues of enablement or allowability, and as such should be entered in its entirety. There are no amendments to the claims.